



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby application of

Masamichi NAKASHIBA et al.

Serial No. 09/589,388

Filed June 8, 2000

APPARATUS FOR AND METHOD
FOR POLISHING WORKPIECE

: Confirmation No. 9958

: Docket No. 2000-0722

: Group Art Unit 3723

: Examiner George Nguyen

RECEIVED

JAN 09 2004

TECHNOLOGY CENTER R3700

PETITION FOR EXTENSION OF TIME

Commissioner for Patents

P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of September 5, 2003.

The fee of \$420.00 is

- (X) submitted herewith.
(to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
(Small entity status of this application is established by a Small Entity Status Assertion which
(is enclosed.
(has been previously submitted.

Respectfully submitted,

Masamichi NAKASHIBA et al.

By:

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January 5, 2004

#29/Ext. f
Time
2 mos.
M. Watts
1/16/04

01/08/2004 SSITHIB1 00000107 09589388
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